# Measuring Microscopes Hyper MF / MF-U



**CATALOG No. E4267-176** 

Measuring Microscopes So Accurate They Defy Common Sense



### World's Highest Measuring Accuracy



#### Concept

Inspecting complex microstructures of ever-decreasing size demands ever-higher accuracy from measuring microscopes used to satisfy the manufacturing and quality control principle of Observation plus Measurement. Mitutoyo is committed to providing microscopes that meet this requirement as well as exceeding users' expectations in terms of sophisticated functionality and ergonomic features that allow fatigue-free use over extended periods of time.

**Mituto**yo

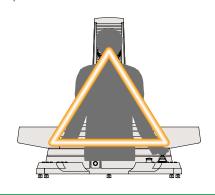
#### **Core Technology**

Over many years Mitutoyo has made significant contributions to the technologies that are key to the core technology of manufacturing industry: measurement. The experience and expertise gained is reflected in the design and manufacture of each individual component of these microscopes and can be seen most clearly in their sublime integration of optics, mechanics, and electronics.



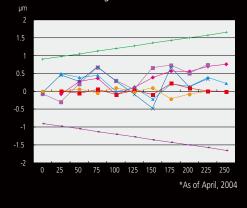
#### **Ergonomic Design**

The microscope main unit has been designed with the emphasis on user friendliness and ease of operation. Mitutoyo has executed the mechanical design to allow easy operation. Even after extended use, its fatigue-fighting design still provides a comfortable work-experience for the operator.



## World's Highest Measuring Accuracy\*

Measuring accuracy in the X- and Y-axes at full stroke surpasses class 0 of the JIS Standard for measuring microscopes (B7153-1995). This makes these microscopes ideal for high accuracy measurement of precision molds or cutting tools that require the best resolution, or for inspecting sub-miniature semiconductor / electronic parts such as wafers and integrated circuits.



#### Large, Highly Accurate XY Stage

Mitutoyo uses a type of linear guideway on the large XY stage that is highly regarded for excellent straightness and stability. This is one key element in the strategy to maximize geometrical accuracy - another is FEM analysis. Our designers used FEM techniques extensively during the design phase to ensure stage stability was optimal in any measurement situation. Thus, the foundations for achieving the highest measuring accuracy were laid.



#### More about the XY Stage

The XY stage is a massive, highly stable design created using mechanical techniques developed over Mitutoyo's long years of experience in manufacturing precision measuring microscopes. Maximum stage loading is 30kgf (66lbf) and a range of useful fixtures is available that includes a wafer holder and swivel-center support.



## Highly Accurate Digital Scales

These microscopes are equipped with highly accurate digital glass scales on all three axes. Mitutoyo produces glass scales in an underground laboratory where the temperature and humidity are constant throughout the year. The XY (stage) and Z (optical tube) displacements are displayed digitally.



### **Excellent Operability and Solid Reliability**



#### **FS Optical System**

The FS optical system is respected more than ever before for its ability to enable measurement, observation and analysis with a leading-edge combination of long working distance and high NA. This optical system ensures high operability when measuring deep holes, steps, etc., or when setting up



## Tilting Optical Tube\*

To reduce fatigue due to extended use, it is important that the operator use a microscope in an unforced posture. The eyepiece unit allows stepless adjustment of tilt angle so that, no matter what their physique, operators can always adjust the viewing position for comfortable working during any measuring task.

\* Available for model MF-U only.



#### LAF Optical Tube\*

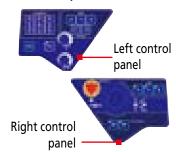
The LAF (Laser AF) optical tube can be selected as an option. The LAF system achieves high repeatability when measuring minute steps, etc., enabling difficult measurements with minimum fatique.

\* Available for model MF-U only



#### **Front Operation**

Controls are arranged to fall within easy reach of the operator on two control panels at the front of the microscope. This allows the operator to concentrate on measurement without having to look away from the eyepieces. Membrane technology makes the switches very durable.

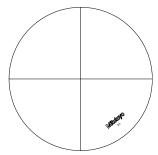


### Measuring with Hyper MF - an Emotional Experience



#### **Cross-hair Reticle**

How accurately the reticle can be aligned with a workpiece feature is a very important feature in a measuring microscope. Taking ocular resolution into account, the thin-line reticle has been standardized on a broken. 90° cross hair with a line width of 5µm\*. This allows precise positioning of the reticle.



\* Cross-hair reticles of 3µm and 7µm line width are also available.

#### Fiber-optic Cold Light Illumination

A fiber-optic cold light illuminator and an IR absorption filter greatly reduce thermal effects on the instrument and workpiece that would otherwise have an adverse effect on measuring accuracy. Telecentric illumination is used for reflected light observation and Koehler illumination

for viewing contours. Both systems use an aperture diaphragm for even, glare-free illumination with good image contrast.



#### System Extensibility

A video port is standard on the optical tube, thereby allowing a digital camera unit and various vision analysis units to be added to



Digital Color Vision System DV-520 (Microscope main unit: MF-UB1010TH)

### **Main Specifications**

#### MF/MF-U

#### **Highest-in-Class Measuring Accuracy**

Mitutoyo has achieved a measuring accuracy of  $\pm$  (0.9+3L/1000)µm (L: Measured length in mm) in both X- and Y-axes. This performance surpasses Class 0\* of JIS B7153:1995, Measuring Microscopes, and allows support of ultra-precise inspection and measurement of the smallest visible features to those extending across the full measuring range of these microscopes.

\* Class 0: (2+0.01L) µm or less, L: Measured length (mm)



#### MF/MF-U

#### Three-axis Motor-driven Joystick Ensures High Operability from High Speed to Ultra-Low speed

The X, Y, and Z axes are driven and controlled with one joystick that serves as the nerve center of front operation. Speed control is possible from high-speed traverse of the stage to ultra low-speed, minute positioning of a workpiece. Also, the lock mechanism is provided for each X, Y, and Z axis to support high-accuracy pitch measurement by single-axis displacement. The primary target is assumed to concentrate the operator on a workpiece.

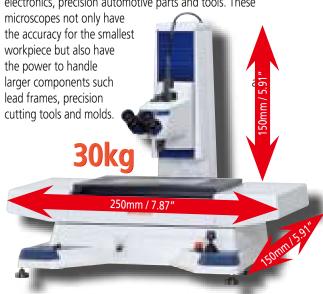


## **Mituto**yo

#### MF/MF-U

#### Large, Highly Accurate XY Stage Handles Wide-field, Heavy-weight Workpieces

The pressures for diversification and up sizing of workpieces are increasing in various industrial fields, such as semiconductors, electronics, precision automotive parts and tools. These



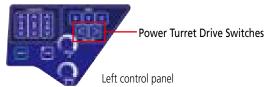
#### MF-U

## Remote-controlled Objective Magnification Change

The power turret in the optical tube is controlled with membrane switches on the left front panel. LEDs indicating each lens position

on the upper part of the optical tube are linked to rotation of the turret so that the operator can see the current magnification at a glance.





#### Laser Auto Focus

#### **LAF Optional Tube**

The laser auto focus function provides high accuracy and high repeatability and brings significant advantage to the inspection of minute steps, multi-layer board detail, etc. A powerful function that helps avoid operator error and ensures high productivity.

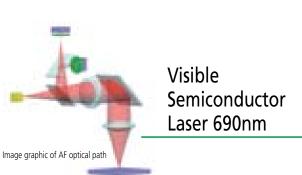


LAF is available both in BF and BD optical tubes.

#### Selectable LAF Functions

Providing a choice of the Just Focus (JF) mode that functions quickly at the current point of interest and the Tracking Focus (TF) mode that tracks the focusing position to retain sharp focus as the stage moves has improved measurement efficiency.









ultra-precision small-sized gear

Wafer





Metal slope 20X





Metal marking 20X

#### LAF Effective in the Smallest Area

An LAF spot diameter of ø1µm or less is achieved using an objective with a magnification of 50X or more. This performance supports a wide range of measurement tasks.

The spot diameters are a logical value determined by calculation.

Objective	Spot diameter
MplanApo 2X	6µm/630µinch
MplanApo 5X	6μm / 240μinch
MplanApo 10X	3μm / 120μinch
MplanApo 20X	1.5µm / 60µinch
MplanApo 50X	0.8µm / 3µinch
MplanApo 100X	0.6um / 2uinch

The AF function delivers highly repeatable focusing on areas with different surface textures and slopes.

#### **Laser Beam Class**

The LAF (factory-fit option) function uses a low-power laser that corresponds to Class 2 (visible light) of JIS C6802/1997, Safety of Laser Products.



Model name		Hyper MF	Hyper MF-U				
Order No.		176-401	176-402				
Optical tube	1	-	(Bright field / bright field LAF / bright and dark field / bright and dark field LAF)*1				
Stand	dard reticle (built-in)	90° broken cross-hair (line width: 5µn	n) Note: Not selectable for Hyper MF-U				
	distance adjustment		ge: 51 to 76mm / 2.01" to 2.99"				
Optio	al path transfer ratio	Observation / video camera = 50/50					
Angle	e from horizontal	25°	Manual tilting				
Video	port	Standard equipment					
Observation	image	Erect	image				
Eyepiece Ma	agnification	10X, 1	5X, 20X				
		Monocular unit (with one eyepiece) or Binocular unit (with two eyepieces) selectable	Provided with two 10X eyepieces				
	ML objective	1X, 3X (standard accessories), 5X, 10X, 20X, 50X, 100X	-				
Objective	Bright field (BF)	-	MplanApo, MplanApo SL, G Plan Apo				
	Bright / dark field (BD)	-	BD Plan Apo, BD Plan Apo SL				
Turret	Bright field (BF)	-	(Centering, parfocal, manual control, 4-way / manual control, 4-way with sensor / centering, motor-driven control, 5-way with sensor*2)				
Turret	Bright / dark field (BD)	-	(Manual control, 4-way / manual control, 4-way with sensor / motor-driven, 4-way with sensor*3)				
Facusina	Maximum workpiece height	150mm / 5.91"					
Focusing Unit	Measuring accuracy*4	±(1.5+10L/1000)µm L: Measured length in mm					
UIIIL	Drive method	Motor-driven control with the joystick					
Illumination	Contour illumination	Koehler illumination, aperture diaphragm built-in, 12V50W halogen bulb, 100-step light adjustment, fiber-optic cold light illumination					
Illumination	Surface illumination	Telecentric illumination, variable aperture diaphragm mechanism, 12V100W halogen bulb, 100-step light adjustment, fib optic cold light illumination					
	Measuring range (X-axis, Y-axis)	250mmx150mm / 9.84"x5.91"					
	Measuring accuracy* (at no load on X- and Y-axis)	$\pm$ (0.9+3L/1000) $\mu$ m L: Measured length in mm					
Stage	Top face dimensions		/ 18.11"x13.78"				
	Effective dimensions of stage glass		n / 11.81"x7.87"				
	Swivel range	±3°					
	Maximum loading	30kgf / 66lbf					
	Drive method	Motor-driven control with the joystick					
Detector uni			scale (Patent registered)				
Digital	Resolution	l · · · · · · · · · · · · · · · · · · ·	.0004µinch				
display	Display axes	,	nd Z axis				
	Data processing unit	`	or Vision Unit				
	Joystick lock		V				
	Fine pitch		V				
	Data output		V				
Control unit	Digital display reset		V				
	Illumination brightness controller		V				
	LAF (Just focus)	-	√ (with LAF installed)				
	LAF Tracking focus	-	√ (with LAF installed)				
	Turret remote-control	-	√ (with the power turret installed)				
External Microscope main unit		880mmx913mmx730mm / 34.65"x35.94"x28.74"	880mmx913mmx770mm / 34.65"x35.94"x30.31"				
dimensions			mm / 6.30"x18.74"x15"				
Mass	Microscope main unit	Approx. 250kg / 551.2lb	Approx. 255kg / 562.2lb				
	Power unit		30.86lb				
Power suppl	У	100, 110, 120, 220, 230, 240VAC 50/60Hz Maximum power consumption 700W					

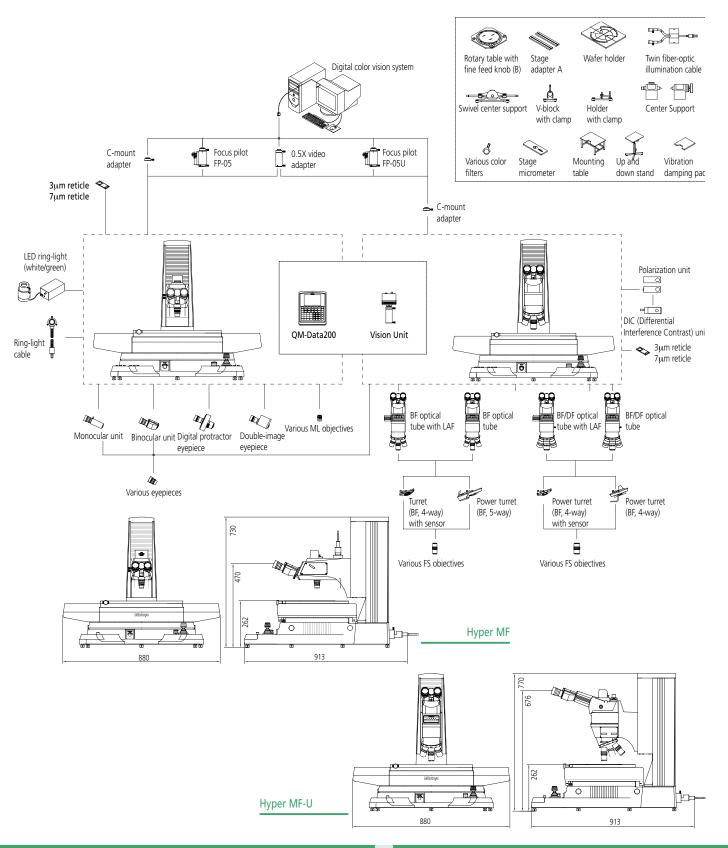


<sup>\*1, 2, 3:</sup> Factory-fit option
\*4, 5: The measuring accuracy conforms to JIS B 7153.

Upon bulb replacement, order the contour illumination halogen bulb 12V50W (02APA527) or surface illumination halogen bulb 12V100W (517181).

The high-brightness specification bulb (12BAD602) is also available as a 12V100W bulb.

### **System Configuration**

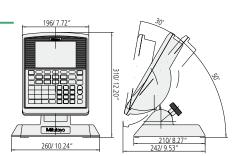


### Data Processing System - 2D Calculating System -



Order No.	264-149				
Display languages	Japanese, English, German, Italian, Spanish, Portuguese, Czech, Chinese, and Korean				
Measurement value unit	Length: mm, angle: degree / degree, minute, second (selectable)				
Resolution	0.01µm				
Programming function	Create / run / edit measuring procedures				
Statistical processing	Measurement item, quantity of data, maximum value, minimum value, mean, standard deviation, range, histogram				
Number of elements in memory	Maximum 1000 elements				
Element call	Point, line, circle, distance, ellipse, square hole, slotted hole, point and angle of intersection				
Element key-in	Point element line element, circle element				
Display unit	Monochrome graphic LCD (320x240 dots, backlighted)				
Input connector	(1) RS-232C [2]: Connected to the counter on the main unit. (2) X, Y, Z: Linear scale input (for the types with no counter) (3) OPTOEYE: OPTOEYE edge signal (for connecting OPTOEYE M2) Note: Available only if linear scale input is used. (4) FS: Connected to the foot switch.				
Output connector	(1) RS-232C [1]: Connected to an external PC (measurement results) (2) PRINTER: Connected to the printer / external printer (measurement results) (3) FD: Connected to the FDD unit (measurement result file, measuring procedure file)				
Measurement result file output	RS-232C output (CSV format, MUX-10 format)				
Power supply	100 to 240VAC, 50/60Hz (AC adapter used)				
Maximum power consumption	24W (excluding optional accessories)				
External dimensions	Approx. 250x242x310mm (including the stand) / 10.24"x9.53"x12.20"				
Mass	Approx. 2.2kg / 4.85lbs				

#### **Dimensions**



## **Mituto**yo

#### **Features**

- > Powerful 2D measurement capabilities with graphic display functions that make the most of the large LCD screen
- > Graphical help on the screen guides the operator during measurement
- > Measurement results are displayed automatically
- > Measurement procedures (Part Programs) can be learnt by the system and easily repeated with position navigation help on screen
- > Frequently-used combination measurements (e.g. circle-to-circle) are single-key operations
- > The Automatic Identification (AI) function recognizes the feature type automatically, making preselection unnecessary
- > Macros to initiate learned measuring sequences can be created at a
- > Custom menus to suit specific requirements can be created
- > Tolerance comparisons and various statistical evaluation options are possible for every measurement result.
- > Measurement results can be output to MS Excel®\* in table form (CSV)
- > Measurement results and Part Programs can be stored on the USB FDD unit or USB-Memory stick available as an optional accessory
- > A free-standing table version with tilting device is available
- > The next measurement can be started even while the last is printing out \* MS-Excel® is a registered trademark of Microsoft Corporation.

#### **USB-Memory Stick**

#### No. 12AAH034

• Used for saving / reading files of part programs, user macros, measurement results, etc.



#### **USB-FDD Unit**

#### No. 12AAH035

• Used for saving / reading files of part programs, user macros, measurement results, etc.



#### **Printer**

#### No. 12AAD032

• Used to print measurement results.

#### [Optional accessories] No. 908353

Printer paper (5 rolls)

Printer control code system: ESC/P, compatible with

Pin-out: 24 pins

ESC/P printer cable(No.12AAA804): 2m- - - Option





Receipt printer print example

Print method	Serial-matrix thermosensitive method
Number of print digits	40 digits
Print speed	Maximum 52.5cps (normal character)
External dimensions (WxDxH)	160x170x65.5mm (printer main unit) / 6.30"x5.59"x2.58"
Standard accessories	Printer cable, printer paper (1 roll), AC adapter (for 100V)



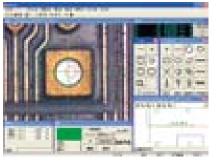
#### **Features**

- > Automatic edge detection tool and measurement macro icons enable single-key measurement
- > Graphics and measurement navigation function support ease of use
- > Image capturing / saving function
- > Tolerancing calculation results and statistical processing for each item
- > Measurement results can be exported to MS-Excel®\* in CSV format (allows unique inspection sheets to be created on the same PC)
- > Supports total measurement on a single screen.
- > Automatic light equalizing function faithfully reproduces illumination conditions
- \* MS-Excel® is a registered trademark of Microsoft Corporation.

#### Measuring a Workpiece Feature



1) Display the feature to be measured on the monitor, adjust the illumination and focus with the microscope main unit, and then select the feature and the edge detection tool.



2) Click in the vicinity of the feature with the mouse to automatically detect its edge and perform the measurement / calculation.



3) The measurement results for the feature selected are displayed on the monitor.

#### **Specifications**

Order No	).	359-680			
Optical s	ystem	0.5X (0.5X video adapter built-in) when Mitutoyo measuring microscope is installed			
lmage d	etecting unit	High-sensitive 1/3" CCD color camera			
External	dimensions of CCD camera	160x170x65.5mm (printer main unit) / 6.30"x5.59"x2.58"			
Mass of	CCD camera	0.4kg / .88lb			
Monitor magnification / monitor visual field (at the use of 3X lens)		Approx. 63X / 3.1x2.3mm / .48"X / .12"x.09" when Mitutoyo measuring microscope is installed			
Resoluti	on	0.01µm / .4µinch			
Measuri	ng accuracy	Depends on the accuracy of the measuring microscope.			
PC	CPU	Pentium 4 2.26GHz 256MB memory			
	Display	15 inch LCD			
	OS	MS-Windows XP*			
	Software	QSPAK			
	Maximum power consumption	Max. 400W			

<sup>\*</sup> MS-Windows XP and MS-Excel® are registered trademarks of Microsoft Corporation. The PC configuration and specifications are subject to change without notice.











#### Lens and Illumination

#### **Eyepieces**

#### Monocular unit ME



With one eyepiece 10X /24

#### Binocular Unit



No. 176-303-1

With two eyepiece 10X /24

#### Eyepiece MF/MF-U







Part name	WF10X / 24	WF15X / 16	WF20X / 12
No. (1-piece pack)	378-856-5	378-857-5	378-858-5
No. (2-piece pack)	378-856	378-857	378-858
Magnification	10X	15X	20X
Field number	24	16	12

#### Double-image eyepiece



#### No. 375-044

Aids accurate measurement of holeto-hole distances, hole diameters and sections using the double image generate when the feature under inspection is not aligned with the optical axis of the microscope.

Magnification: 10XField number: 22

#### Rotary template eyepiece

MF





#### No. 176-357

Uses a template to superimpose screw thread forms (metric UST, Uni-field Screw Thread), concentric circles, and crosshairs on the workpiece image for quick and efficient measurement by comparison.

- Magnification: 10X
- Field number: 21

(for 3X objective)	0.25, 0.3, 0.4, 0.45, 0.5, 0.6, 0.7, 0.75, 0.8, 0.9, 1, 1.25, 1.5, 1.75, 2, 2.5, 3, 3.5, 4
ISO unified screw thread / inch (for 3X objective)	80, 75, 64, 56, 48, 44, 40, 36, 32, 28, 24, 20, 18, 16, 147, 13, 12, 11, 10, 9, 8, 7, 6
Concentric circles with cross hairs (for 3X objective)	ø1, ø2, ø3, ø4, ø5
Dotted-line cross scale	60°, 90°

#### Protractor eyepiece



#### No. 375-043

Measures angle between workpiece edges by successive alignment with two crosshairs whose separation is adjustable and calibrated through 360°

- Field number: 21
- Resolution: 5'



#### Digital protractor eyepiece MF

#### No. 176-313

Measures angle between workpiece edges by successive alignment with reticle cross hairs whose rotation is digitally calibrated. Switching or resetting the resolutions is controlled with the standard accessory counter. Data output to an RS-232C equipped PC is possible.

• Magnification: 10X •Field number: 18 •Reticle: 90° solid line, 45° broken line •Angular resolution: 0.00° or 1° •Power supply: 9VAC, 600mA •Maximum power consumption: 4W •Maximum angle value: ±369.99° or ±369.59′



#### Objective

#### **ML** Objective

MF

Model name	ML1X	ML3X	ML5X	ML10X	ML20X	ML50X	ML100X
Order No.	375-036-1	375-037-1	375-034-1	375-039	375-051	375-052	375-053
Magnification	1X	3X	5X	10X	20X	50X	100X
Numerical aperture N.A.	0.03	0.07	0.13	0.185	0.42	0.55	0.7
Working distance WD	61mm / 2.40"	77mm / 3.03"	61mm / 2.40"	51mm / .2.32"	20mm / .79"	13mm / .51"	6mm / .24"
Focal depth	306µm / 12.05µinch	34µm / 1.33µimch	16.3µm / .64µinch	6.2µm / .24µinch	1.6µm / .06µinch	0.9µm / .94µinch	0.6µm / .02µinch

#### FS Objective Bright field (BF)

MF/MF-U

Model name	MplanApo 1X	MplanApo 2X	MplanApo 5X	MplanApo10X	MplanApo 20X	MplanApo 50X	MplanApoHR50X	MplanApo 100X	MplanApoHR100X
Order No.	378-800-3	378-801-3	378-802-6	378-803-3	378-804-3	378-805-3	378-814-4	378-806-3	375-815-4
Magnification	1X	2X	5X	10X	20X	50X	50X	100X	100X
Numerical aperture N.A.	0.025	0.055	0.14	0.28	0.42	0.55	0.75	0.7	0.9
Working distance WD	11mm / .43"	34mm / 1.33"	34mm / 1.33"	34mm / 1.34"	20mm / .79"	13mm / .51"	5.2mm / .20"	6mm / .24"	1.3mm / .05"
Focal depth	550µm / 17.32µinch	91µm / 3.58µinch	14µm / .55µinch	3.5µm / .14µinch	1.6µm / .06µinch	0.9µm / .04µinch	0.48µm / .02µinch	0.6µm / .02µinch	0.34µm / .01µinch
Model name	MplanApoSL20X	MplanApoSL50X	MplanApoSL80X	MplanApoSL100X	MplanApoSL200X	GplanApo20X(t2.5	) GplanAPo50X(t3.5	)	

Model name	MplanApoSL20X	MplanApoSL50X	MplanApoSL80X	MplanApoSL100X	MplanApoSL200X	GplanApo20X(t2.5)	GplanAPo50X(t3.5)
Order No.	378-810-3	378-811-3	378-812-3	378-813-3	378-816-3	378-847	378-848-5
Magnification	20X	50X	80X	100C	200X	20X	50X
Numerical aperture N.A.	0.28	0.42	0.5	0.55	0.62	0.28	0.5
Working distance WD	30.5mm / 1.2"	20.5mm / .81"	15mm / .59"	13mm / .51"	13mm / .51"	29.42mm / 1.16"	13,89mm / .55"
Focal depth	3.5um / .14uinch	1.6um / .09uinch	1.1um / .04uinch	0.9um / .04uinch	0.7um / .03uinch	3.5um / .14uinch	1.1um / .04uinch

#### FS Objective Bright / dark field (BD) MF/MF-U

Model name	BDplanApo2X	BDplanApo5X	BDplanApo10X	BDplanApo20X	BDplanApo50X	BDplanApoHR50X	BDplanApo100X	BDplanApoHR100X
Order No.	378-831-5	378-832-6	378-833-5	378-834-5	378-835-5	378-845	378-836-5	378-846
Magnification	2X	5X	10X	20X	50X	50X	100X	100X
Numerical aperture N.A.	0.055	0.14	0.28	0.42	0.55	0.75	0.7	0.9
Working distance WD	34mm / 1.34"	34mm / 1.34"	34mm / 1.33"	20mm / .79"	13mm / .51"	5.2mm / .20"	6mm / .24"	1.3mm / .05"
Focal depth	91µm / 3.58µnch	14μm / .55μinch	3.5µm / .15µinch	1.6µm / .96µinch	0.9µm / .04µinch	0.48µim / .03µinch	0.6µm / .02µinch	0.34µm / .01µinch

Model name	BDplanApoSL20X	BDplanApoSL50X	BDplanApoSL80X	BDplanApoSL100X
Order No.	378-840-5	378-841-5	378-842-5	378-843-5
Magnification	20X	50X	80X	100C
Numerical aperture N.A.	0.28	0.42	0.5	0.55
Working distance WD	30.5mm / 1.2"	20mm / .79"	13mm / .51"	13mm / .51"
Focal depth	3.5µm / .14µinch	1.6µm / .09µinch	1.1µm / .04µinch	0.9µm / .04µinch

## Twin fiber-optics illuminator MF

## Fiber-optics ring-light

MF/MF-U

#### LED ring-light

#### LED ring-light

(for FS Objectives)

MF-U



No. 176-416

This uses the surface illumination light source in microscope main unit. The light equalizing function and condenser lens are included. 12V100W

\*10X lens or less is applicable.



No. 172-417

This uses the surface illumination light source in microscope main unit. The light equalizing function and condenser lens are included. 12V100W

\*10X lens or less is applicable.



**No. 172-367** (white LED)

**No.176-368** (Green LED)

Position is adjustable so as to be appropriate for the light equalizing function and working distance. 12V 7.7W, outside diameter:70mm/2.76" \*10X lens or less is applicable.



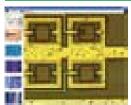
**No. 78829** (white LED)

Position is adjustable so as to be appropriate for the light equalizing function and working distance. 12V7.7W, outside diameter: 70mm/2.76"

\*10X lens or less is applicable.

### **Main Optional Accessories**

#### **Digital Color Vision**



C-mount compatible high-definition digital color vision system. Allows anyone to easily capture and save high quality images from the microscope.

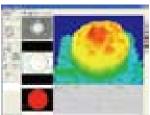
Three types: 5.2M pixel, 2.1M pixel, and 0.5M pixel.

•Main functions Image filing, on-screen manual measurement, white balance, comments on an image, scale display, etc.

**No.176-380**: DV-50CL (LCD spec) **No.176-384**: DV-210L (LCD spec) **No.176-382**: DV-520L (LCD spec)

\* On-screen manual measurement requires the calibration chart (02AKN020) separately.

#### 3D Vision Combination Program VCPAK



This system is based on an omnifocal image focused in the whole visual field of the microscope to greatly improve observation at small depths of focus. It also enables 3D vision display.

 Main functions High-quality digital imaging, real-time vision combination by capturing a maximum of 256 sheets of images, adoption of universal image file formats (JPEG, BMP, TIFF, DIB), thumbnail display of saved images, noise reduction function, etc.

## Polarization Unit



No.378-092 Bright field (BF) Bright and dark field (BD)

#### **DIC Unit**



No.378-080: For 5X, 10X No.378-079: For 20X No.378-078: For 50X, SL20X No.378-076: For 100X, SL80X, SL50X

## Illumination Filter



No.12AAA643:ND2 No.12AAA644:ND8 No.12AAA645:GIF No.12AAA646:LB80

#### Centering, Parfocal Turret



Objectives: Up to 4
Visual field adjustment range: ±0.5mm/.02"
Parfocal adjustment range: ±0.5mm/.02"

## Power Turret (for BF)



Objectives: Up to 5
Visual field adjustment range: ±0.5mm/.02"
Positioning accuracy: 2 $\sigma$ =3 $\mu$ m/120 $\mu$ inch

Drive life: 1,000,000 movements

#### V Block with Clamp



No.172-378 Maximum clamp diameter: ø25mm/.98" Mass: 0.8kg/ 1.76lb \* Stage Adapter A is used together.

#### Swivel Center Support



A tilt angle of  $\pm 10^\circ$  can be supported. Minimum reading of angle:  $1^\circ$  Maximum support size:  $\emptyset 80x140$ mm/ 3.15''x5.51'' in horizontal orientation  $\emptyset 65x140$ mm/ 2.56''x5.52'' at a tilt angle of  $10^\circ$ 

Mass: 2.5kg/ 5.51lb \* Stage Adapter A is required.

## Holder with Clamp



Maximum workpiece thickness: 35mm/ 1.38" Mass: 0.4kg/ .88lb \* Stage Adapter A is required.

#### Wafer Holder



No.176-414 Wafer size: 3 to 8 inches Rotary Holder (No.378-363) attached Mass: 3.2kg/ 7.06lb

#### **Center Support**





Maximum support length: 250mm/9.84" Maximum support diameter: ø150mm/5.91" Maximum diameter allowing external

Maximum diameter allowing external apex observation: Ø140mm/5.51" Effective stroke of the center-clamping mechanism: 22mm/ .87" Mass: 13kg/ 28.66lb

## Stage Adapter



**No.176-3042** pieces pack Mass: 1.5kg/ 3.31lb

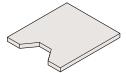
## Rotary table with fine feed knob (B)



No.3176-306 Effective glass diameter: ø240mm/9.45 Rotary table rotation angle: Approx. 51.5° (per full turn of the fine feed

Mass: 6.5kg/ 14.33lb

## Vibration Damping Pad



No.176-419 Spring pad type Float unit material: SUS304 WXDxH = 800x900x49mm/ 31.50"x35.43"x1.93" Mass: 58kg/ 127.9lb

#### Machine Stand



No.176-418 Max. loading: 400kgf/ 881.8lbf WxDxH = 1100x900x650mm/ 433.07"x35.43"x26.59" Mass: 45kg/99.21lb



### Measuring Microscope Line-up

Demand for measuring microscopes that can perform observational tasks as well as measurement is increasing rapidly in various sectors of industry such as semiconductors, electronic parts, precision auto parts and tools. The following summarizes Mitutoyo's line-up of measuring microscopes actively participating in many industries. Mitutoyo intends to widen the appeal of measuring microscopes that can determine miniscule part dimensions on a workpiece and make them serve as the Basic Machine for non-contact measurement.

#### **High-accuracy Measuring Microscopes**



# | Measuring range (X·Y·Z) | 250·150·150mm | | Control system/ reading unit | Resolution | QM-DATA200/vision unit | Video port | Standard equipment |

Hyper MF

Standard

Hyper MF-U

Metallurgical microscope

#### **Measuring Microscopes**



Series name	MF	MF-U
Optical tube	Standard (finite distance compensation)	Metallurgical microscope (finite distance compensation)
Measuring range	50-50-150/100-100-150/200-100-150/200-170-220/	
$(X \cdot Y \cdot Z)$	300·170·220/400·200·220mm	
Control system/	Manual/digital scale	
reading unit		
Resolution	0.1 / 0.5 / 1µm	
Data processing unit	QM-DATA200/vision unit	
Video port	Standard equipment	

#### Toolmaker's Microscope



Series name	TM
Optical tube	Standard (finite distance compensation)
Measuring range (X·Y·Z)	50·50·115/100·50·107mm
Control system/ reading unit	Manual/micrometer head
Resolution	1 (MHD head)
Data processing unit	QM-DATA200
Video port	None



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Coordinate Measuring Machines

Vision Measuring Systems

Form Measurement

**Optical Measuring** 

Sensor Systems

Test Equipment and

Digital Scale and DRO Systems

Small Tool Instruments and Data Management

#### **Mitutoyo Corporation**

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